



Attorney's Docket No.: 004711/P1

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)

Steven Verhaberbeke et al.)

Application No: 09/891,849)

Examiner: Markoff, Alexander

Filed: June 25, 2001)

Art Unit: 1792

For: METHOD AND APPARATUS FOR
WAFER CLEANING)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**AMENDMENT UNDER
37 C.F.R. §1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1792**

AMENDMENT AFTER FINAL

Dear Sir:

This is in response to the Office Action mailed March 21, 2008. Pursuant to 37 C.F.R. § 1.116 Applicant respectfully requests the Examiner to enter this Amendment after Final which complies with the Examiner's requirements of form expressly set forth in the previous Office Action mailed March 21, 2008.

DO NOT ENTER: /AM/

06/09/2008

FIRST CLASS CERTIFICATE OF MAILING

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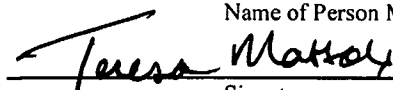
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U.S. Patent and Trademark Office, Washington, D.C. 20231 on May 12, 2008

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Signature

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Date